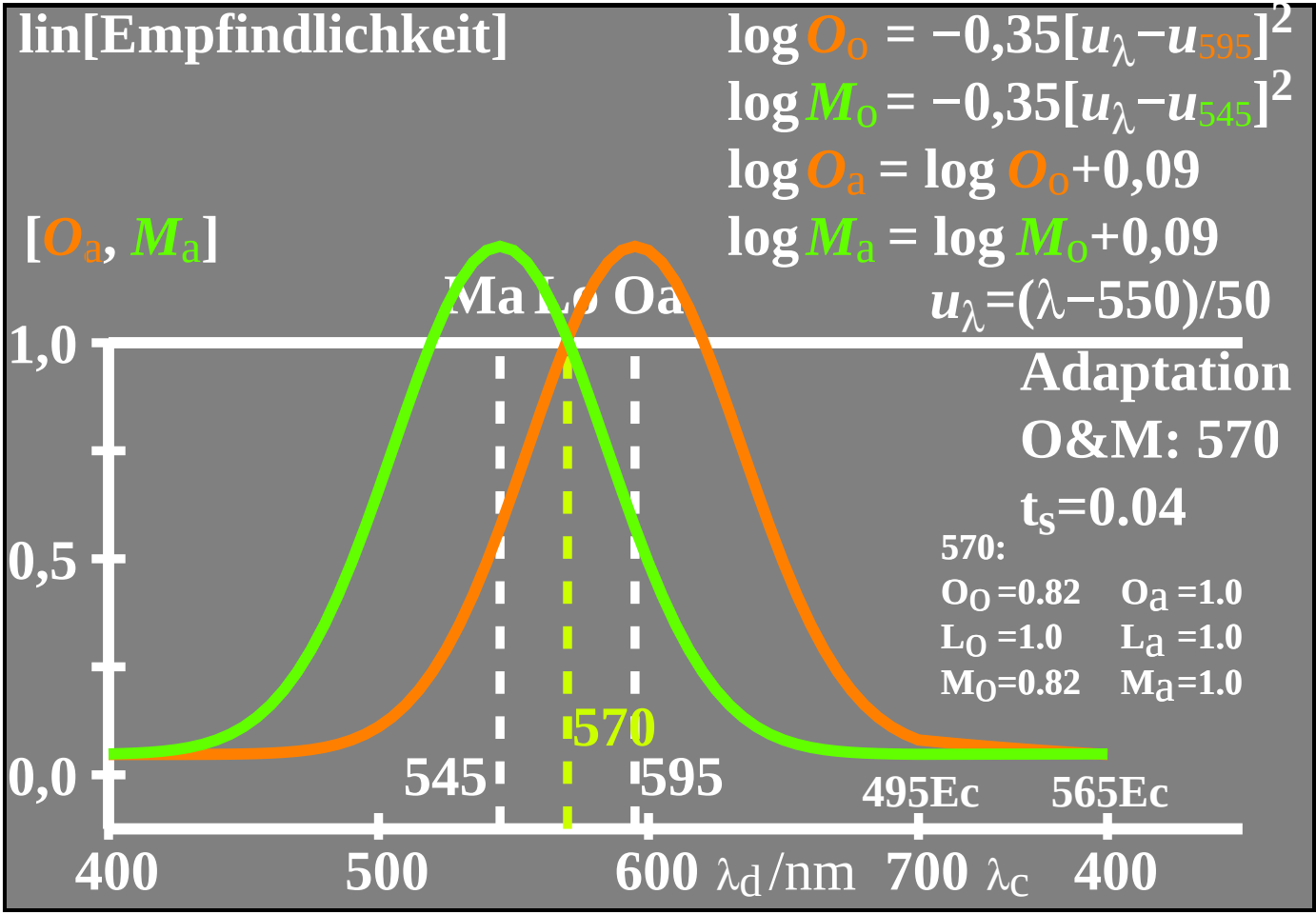
lin[Empfindlichkeit]
log Oo = −0,35[uλ−u595]2
log Mo = −0,35[uλ−u545]2
log Oa = log Oo+0,09
log Ma = log Mo+0,09
uλ=(λ−550)/50
[Oa, Ma]
Ma Lo Oa
Adaptation
O&M: 570
ts=0.04
570:
Oo =0.82 Oa =1.0
Lo =1.0 La =1.0
Mo=0.82 Ma=1.0
1,0
0,5
0,0
570
545
595
495Ec
565Ec
400
500
600 λd/nm
700 λc
400

egx31−1a